



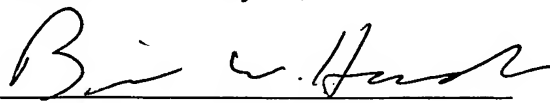
JC10 Rec'd PCT/PTO 8 1 JUL 2005

PCT

Certification under 37 CFR 1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to THE COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450 on July 19, 2005.

Brian W. Hameder (Reg. No. 45,613)
Name


Signature

DOCKET: CU-4207

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Guoshun DENG et al.

Serial No.: 10/534,928

Group Art Unit:

Filed: May 13, 2005

Examiner:

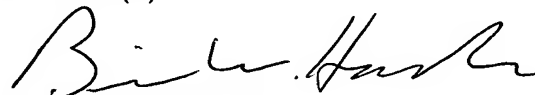
For: METHOD FOR REALIZING DATA SECURITY STORAGE AND ALGORITHM
STORAGE BY MEANS OF SEMICONDUCTOR MEMORY DEVICE

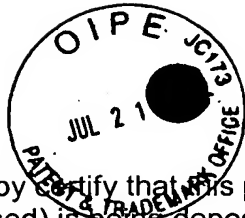
THE COMMISSIONER FOR PATENTS
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**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT WITHIN THREE
MONTHS OF FILING OR BEFORE MAILING OF FIRST OFFICE ACTION**

The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of the first Office Action on the merits, whichever event occurs last. 37 CFR 1.97(b).

Date: July 19, 2005


Signature of Attorney
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INFORMATION DISCLOSURE STATEMENT

Applicants submit herewith patents, publications or other information of which the applicants are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose under 37 CFR 1.56.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

The references submitted herein are listed on PTO-1449 form (modified) enclosed herewith. A copy of each reference listed is being furnished except any duplicate or cumulative patents or publications specified otherwise. Also, if the present application was filed after June 30, 2003, copies of US patents or published applications are not submitted in accordance with the USPTO Rule changes.

A translation of any foreign language reference, if any, is indicated in PTO-1449 form and being submitted herein if it is readily available. Otherwise it should be construed that such translation is not readily available.


Additional comments, if any, on the relevance of each reference listed are provided as follows:

The Statement is made on the basis of the information:

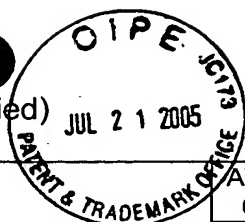
<u> </u>	supplied by the inventor(s);
<u> X </u>	supplied by an individual associated with the filing and prosecution
<u> </u>	of this application (37 CFR 1.56(c)); or
<u> </u>	in the attorney's file.

Respectfully submitted,

Date: July 19, 2005



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FORM PTO-1449

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(37 CFR 1.98(b))

 ATTY. DOCKET NO.
Cu-4207

 SERIAL NO.
10/534,928

 APPLICANT
Guoshun DENG et al.

 FILING DATE
May 13, 2005

GROUP

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT DOCUMENT	ISSUE/PUB DATE	PATENTEE	CLASS	SUB- CLASS	FILING DATE
	6,112,187	8.29.00	Fukawa			
	6,859,535	2.22.05	Tatebayashi et al.			

FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

EXAMINER INITIAL	DOCUMENT NUMBER	PUBL. DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB- CLASS	TRANSLATION	
						YES	NO
	1317744	10.17.01	CHINA				
	1199892	11.25.98	CHINA				
	1256459	6.14.00	CHINA				
	1098471	5.09.01	EPO				

OTHER DOCUMENTS (Including Author, Title, Date, Place of publication)

(Form PTO-1449)